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PATENT  
Docket No. P1296

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IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): BIN YU

SERIAL NO.: 09/826,472

EXAMINER: RON E. POMPEY

FILED: APRIL 4, 2001

ART UNIT: 2812

FOR: METHOD OF FABRICATING A SEMICONDUCTOR DEVICE  
HAVING A NITRIDE/HIGH-K/NITRIDE GATE DIELECTRIC STACK  
BY ATOMIC LAYER DEPOSITION (ALD) (as herein amended)

BOX NON-FEE AMENDMENT  
COMMISSIONER FOR PATENTS  
WASHINGTON, DC 20231

RESPONSE TO OFFICE ACTION

To the Commissioner:

This letter is a Response to the Office Action dated August 20, 2002. The Applicant is respectfully requesting favorable consideration of the below-submitted amendment and remarks.